

*JAW*  
PATENT



IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE

Applicant: Won Kwon Lee

Serial No.: 10/622,532

Filed: July 18, 2003

For: METHOD FOR FORMING  
ISOLATION FILMS IN  
SEMICONDUCTOR DEVICES

Group Art Unit: 1765

Examiner: DuyVu n. Deo

I hereby certify that this paper (or fee) is being deposited with the United States Postal Service, first class postage prepaid, addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

September 14, 2005

  
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James P. Zeller  
Reg. No. 28,491

AMENDMENT "A"

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application as follows:

the amendments to the claims section begins on page 2 of this paper; and  
the remarks begins on page 7 of this paper.